Linnell, Orville G.   LaGrange, Ill.
B.S. in Chemical Engineering
Lyons Township High School, LaGrange, Ill.
Sigma Kappa Delta; Alpha Chi Sigma,
President; Phi Lambda Upsilon; Rifle Club,
Team 3, 4, Manager 3; A.I.Ch.E., Secretary 3; Campus Club 2, 3; Armour Tech
News 2; Election Committee 3, 4, Chairman 3; Social Committee 3; Photography
Committee 4.

Long, Russell E.   Aurora, Ill.
B.S. in Chemical Engineering
East High School, Aurora, Ill.
Theta Xi; A.I.Ch.E. 2, 3, 4; Assistant
Junior Marshal; Jacket Committee 4.

Longwell, Robert C.   Chicago, Ill.
B.S. in Mechanical Engineering
Tilden Technical High School, Chicago, Ill.
A.S.M.E. 3, 4.

McCall, James S.   Homewood, Ill.
B.S. in Mechanical Engineering
Thornton Twp. High School, Harvey, Ill.
Pi Tau Sigma; Pi Nu Epsilon; Sphinx;
Glee Club 2, 3, 4; A.S.M.E. 3, 4, Treasurer
4; Press Club 3; Armour Tech News 2, 3, 4,
Circulation Manager 4; Announcement Committee 4.

McGill, Thomas A.   Chicago, Ill.
B.S. in Electrical Engineering
Austin High School, Chicago, Ill.
Tau Beta Pi; Eta Kappa Nu; Pi Nu Epsilon; A.I.E.E., Vice-Chairman 4; Class
Treasurer 4; Secretary and Treasurer of
Musical Clubs 4; Chairman Jacket Committee 4; Orchestra 1, 2, 3.

Magnuson, Edward G.   Chicago, Ill.
B.S. in Fire Protection Engineering
Crane Technical High School, Chicago, Ill.
Campus Club 1, 2, 3, 4; Glee Club 2.

Matheson, Donald R.
          Granum, Alberta, Canada
B.S. in Electrical Engineering
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Rifle Club 1, 2, 3; Team 2; Radio Club 4;
A.I.E.E. 2, 3, 4.

Meagher, Richard E.   Chicago, Ill.
B.S. in Civil Engineering
Englewood High School, Chicago, Ill.
Tau Beta Pi; Chi Epsilon; Honor A Society; W.S.E. 2, 3, 4; Manager Interfraternity Athletics 3; Golf Manager 3; Interhonorary Council 3.

Melcarek, Leonard V.   Chicago, Ill.
B.S. in Chemical Engineering
Lindblom High School, Chicago, Ill.
Beta Psi; Alpha Chi Sigma; A.I.Ch.E.

Meuret, James A.   Chicago, Ill.
B.S. in Electrical Engineering
Roosevelt High School, Chicago, Ill.
Eta Kappa Nu; A.I.E.E. 3, 4.